Page 1 of 8

Appln No.: 09/900,743 Page 1 of Applicant(s): Yu-Chong Tai et al.
SURFACE-MICROMACHINED PRESSURE SENSOR AND HIGH PRESSURE APPLICATION

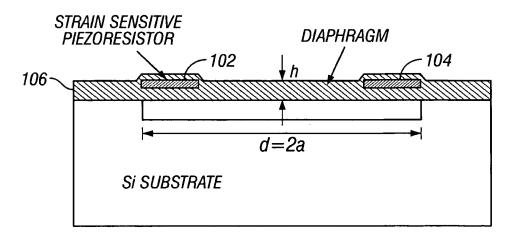
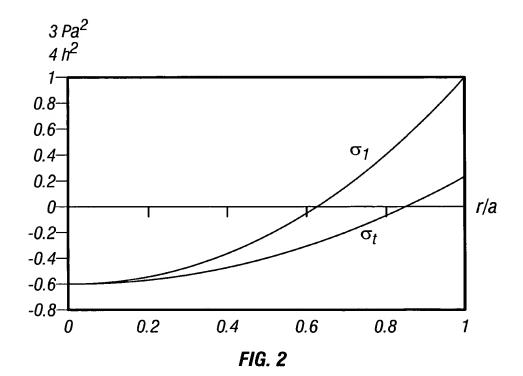


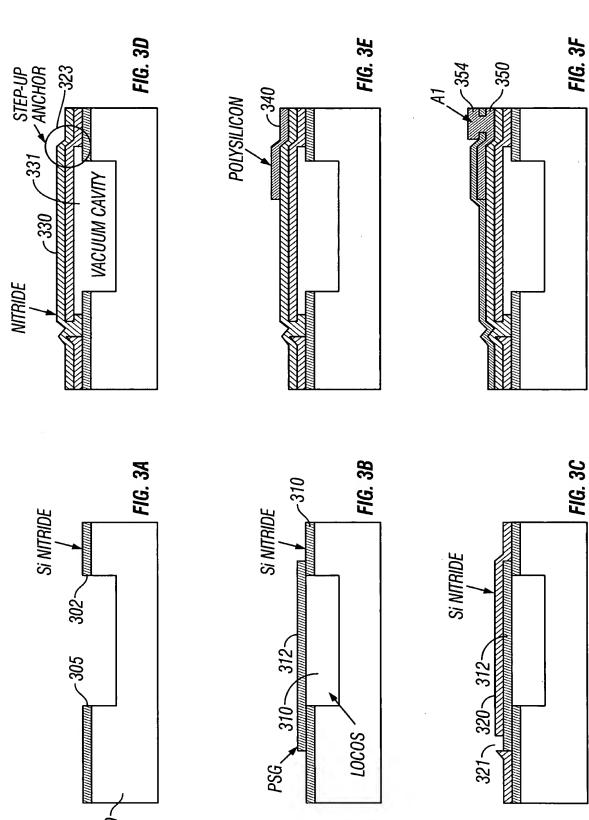
FIG. 1





Appln No.: 09/900,743 Page 2 of Applicant(s): Yu-Chong Tai et al.
SURFACE-MICROMACHINED PRESSURE SENSOR AND HIGH PRESSURE APPLICATION

Page 2 of 8





Appln No.: 09/900,743 Page 3 o Applicant(s): Yu-Chong Tai et al. SURFACE-MICROMACHINED PRESSURE SENSOR AND HIGH PRESSURE APPLICATION

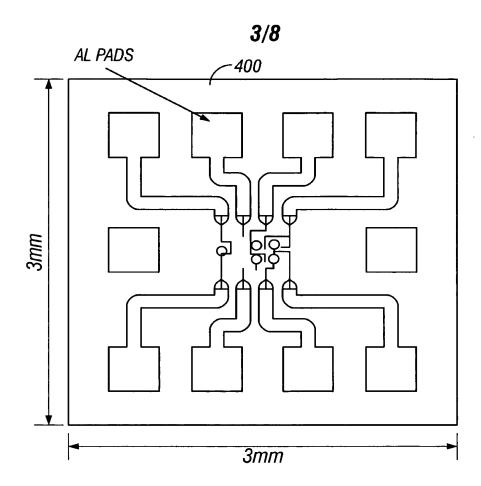


FIG. 4

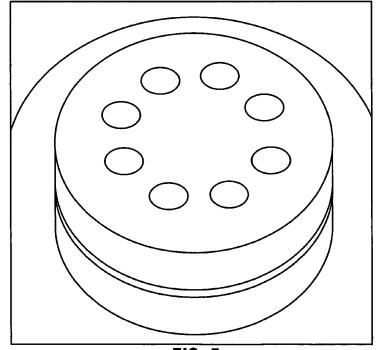
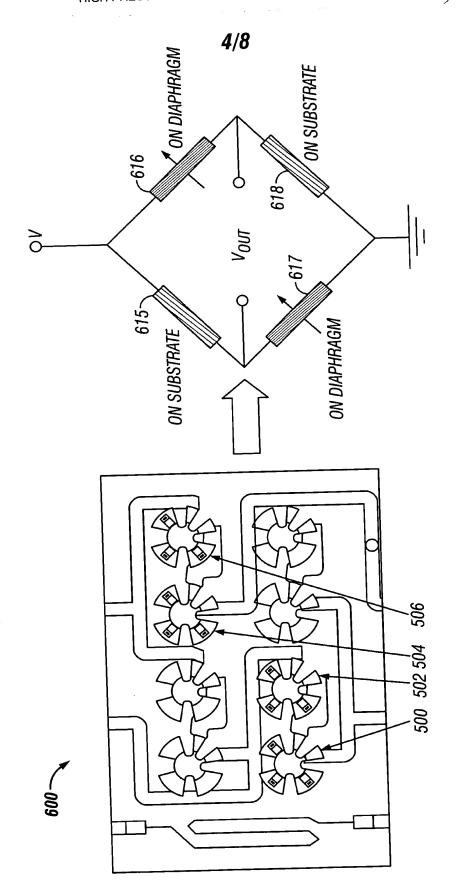


FIG. 5



Applin No.: 09/900,743 Page 4 c Applicant(s): Yu-Chong Tai et al. SURFACE-MICROMACHINED PRESSURE SENSOR AND HIGH PRESSURE APPLICATION

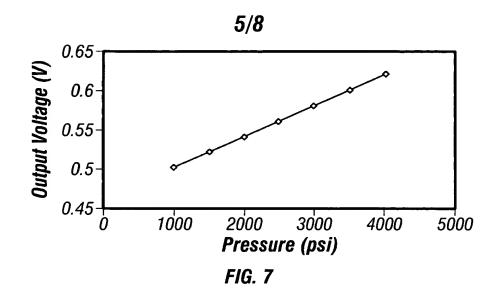


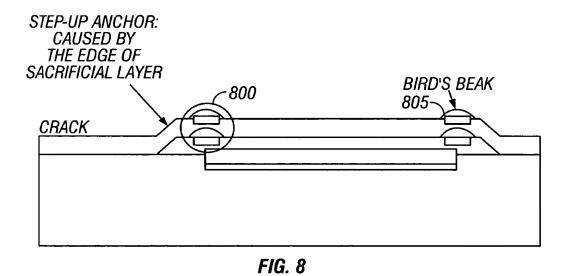
Appln No.: 09/900,743 Applicant(s): Yu-Chong Tai et al.

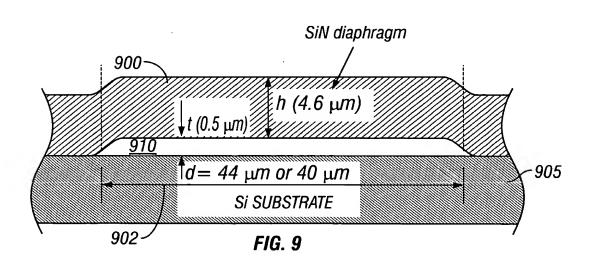
SURFACE-MICROMACHINED PRESSURE SENSOR AND

Page 5 of 8

HIGH PRESSURE APPLICATION



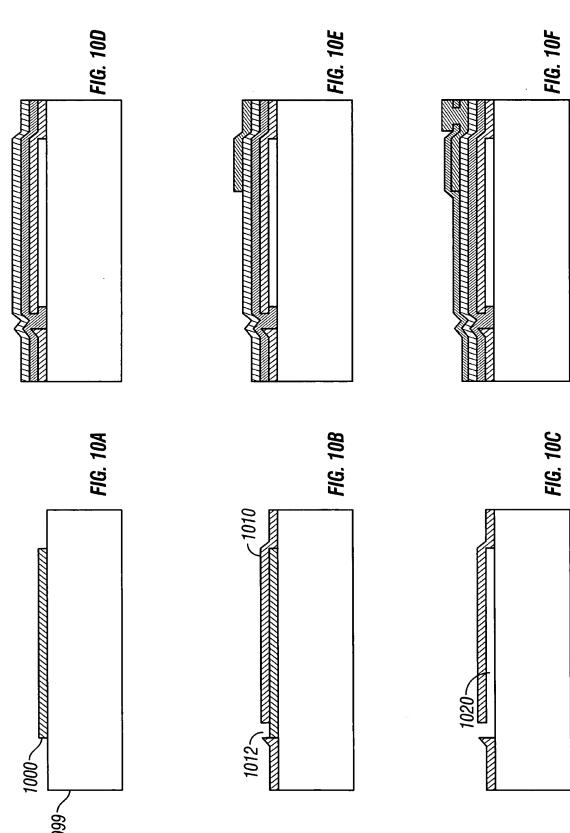




Page 6 of 8

Appln No.: 09/900,743 Page 6 of Applicant(s): Yu-Chong Tai et al.
SURFACE-MICROMACHINED PRESSURE SENSOR AND HIGH PRESSURE APPLICATION





Appln No.: 09/900,743 Page 7 of Applicant(s): Yu-Chong Tai et al. SURFACE-MICROMACHINED PRESSURE SENSOR AND

Page 7 of 8

HIGH PRESSURE APPLICATION

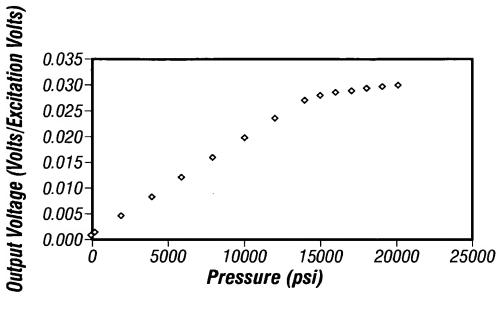
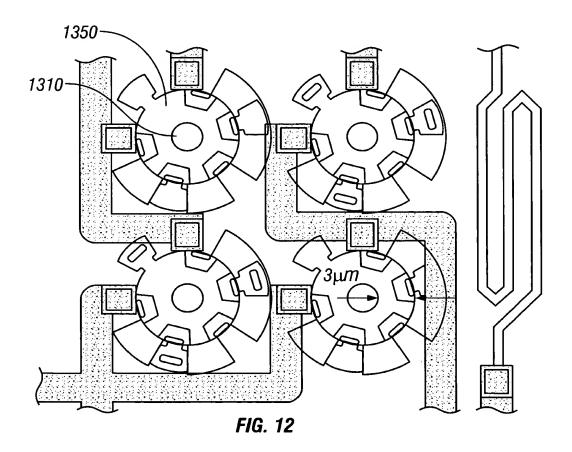


FIG. 11





Appln No.: 09/900,743 Page 8 of Applicant(s): Yu-Chong Tai et al.
SURFACE-MICROMACHINED PRESSURE SENSOR AND HIGH PRESSURE APPLICATION

Page 8 of 8

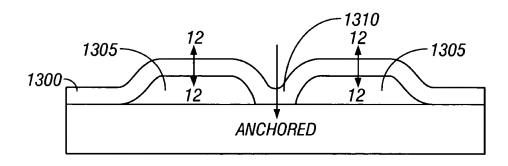


FIG. 13